

B

03560.002758

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ryuichi EBINUMA et al.

Application No.: 09/817,018 ✓

Filed: March 27, 2001

For: SUPPORTING STRUCTURE OF OPTICAL
ELEMENT, EXPOSURE APPARATUS
HAVING THE SAME, AND
MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE

)
: Examiner: H. Nguyen
)
: Group Art Unit: 2851
)
: Confirmation No.: 7324
)
: Allowed: November 14, 2003
)
: November 25, 2003
)

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

LETTER REQUESTING CONSIDERATION
OF PAPERS TIMELY FILED

Sir:


Applicants have received a Notice of Allowance and a Notice of Allowability dated November 14, 2003, in the above-identified application. Applicants filed a Third Supplemental Information Disclosure Statement on September 22, 2003, prior to issuance of the Notice of Allowance and Notice of Allowability on November 14, 2003. To date, those papers have not been indicated as being considered by the Examiner. Accordingly, Applicants request that the Examiner consider the material submitted in the Third Supplemental Information Disclosure Statement filed on September 22, 2003, by returning a copy of the initialed PTO-1449 form attached to that Information Disclosure Statement. Attached, for the Examiner's convenience, are copies of the Third Supplemental

Information Disclosure Statement, the PTO-1449 form, and the U.S. Patent and Trademark Office date stamped postcard receipt indicating the filing of those papers on that date.

Applicants believe that no fees should be incurred in connection with filing this paper. However, the Commissioner is authorized to charge Deposit Account No. 06-1205, should any fees be associated herewith. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW/eab

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date 9, 23, 03
Mo. Day Yr.

Atty. Docket 03560, 002758
Application No. 02/2018

Sir:

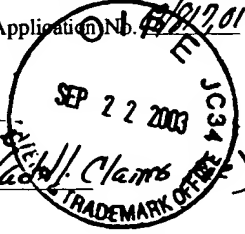
Kindly acknowledge receipt of the accompanying:

- ☒ Response to Official Action. 6/23/03
- ☒ Check for \$ 180- (claims fee) IDS Fee
- ☒ ~~Petition under 37 CFR 1.136 and~~ Check for \$ 250- (advs. Claims)
- ☐ Notice of Appeal and Check for \$ _____
- ☒ Information Disclosure Statement, PTO-1449 and _____ documents
- ☐ Claim for priority and certified copies of _____ priority applications
- ☐ Issue fee transmittal and Check for \$ _____
- ☒ Other (specify) Amendment After Final Rejection (w/ITS)

by placing your receiving date stamp hereon and returning to deliverer.

Atty. SEW/SWF:eyw Due Date 9, 23, 03
Mo. Day Yr.

FOHS-D-00





BOX AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINER GROUP 2851

03560.002758

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
RYUICHI EBINUMA, ET AL.) : Examiner: Hung Nguyen
Application No.: 09/817,018) : Group Art Unit: 2851
Filed: March 27, 2001) :
For: SUPPORTING STRUCTURE OF OPTICAL) : September 22, 2003
ELEMENT, EXPOSURE APPARATUS) :
HAVING THE SAME, AND MANUFACTURING) :
METHOD OF SEMICONDUCTOR DEVICE) :

Mail Stop AF
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450

THIRD SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

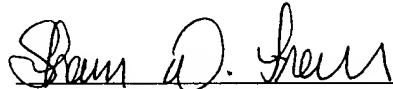
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

Applicants requests that the above information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

This Information Disclosure Statement is being filed after the mailing of a first Official Action on the merits of the application. Accordingly, Applicants submit herewith the requisite fee of \$180.00 for consideration of the Information Disclosure Statement. The Commissioner is authorized to charge any deficiency in payment and/or credit any overpayment to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed for that purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Shawn W. Fraser", is written over a horizontal line.

Attorney for Applicants

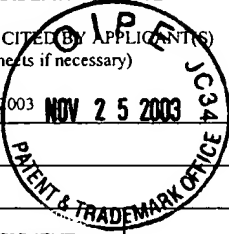
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SEW:SWF:eyw

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Submitted to the PTO: September 22, 2003				ATTY DOCKET NO. 03560.002758		APPLICATION NO. 09/817,018	
				APPLICANT RYUICHI EBINIUMA, ET AL.			
				FILING DATE March 27, 2001		GROUP 2851	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,220,657	04/24/2001	Rea	296	220.01	
		6,295,118	09/25/2001	Takeuchi	355	52	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		11-44834	02/16/1999	Japan			Abstract
		11-231192	08/27/1999	Japan			Abstract
		2001-242364	09/07/2001	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

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